

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 12, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG659455539

LABORATORY GROWN DIAMOND

EMERALD CUT

7.81 X 5.48 X 3.67 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.53 CARAT

H

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG659455539

PROPORTIONS

Medium


68%

13%

50.5%

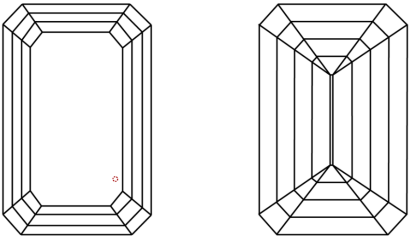
67%

Long



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Internally Flawless

Very Very Slightly Included



Very Slightly Included

Slightly Included


Included

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
EXCELLENT

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IGI

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EMERALD CUT

7.81 X 5.48 X 3.67 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

1.53 CARAT

H

VVS 2

67%

65%

Medium

Long

EXCELLENT

EXCELLENT

NONE

 LG659455539

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

None

EXCELLENT

EXCELLENT

NONE

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